Docket No.: 4887P327D2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:

SHAHAB KHANDAN, ET AL.

Application No.:

Filed:

METHOD FOR CVD PROCESS For:

CONTROL FOR ENHANCING DEVICE

PERFORMANCE

Art Group: 2812

David A. Zarneke Examiner:

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

In accordance with the duty of disclosure, enclosed is a copy of Information Disclosure Sir: Statement by Applicant (form PTO/SB/08), which is being submitted concurrently with the Divisional Application. It is respectfully requested that the cited references be considered and that the enclosed copy of PTO/SB/08 be initialed by the Examiner to indicate such consideration and a copy thereof returned to applicant(s).

The submission of this Information Disclosure Statement is not to be construed as a representation that a search has been made in the subject application and is not to be construed as an admission that the information cited in this statement is material to patentability.

Please charge any fees due to Deposit Account 02-2666. A duplicate copy of the Fee Transmittal (PTO/SB/17) is enclosed for this purpose.

Respectfully submitted,

Blakely, Sokoloff, Taylor & Zafman LLP

Date: 9/16/03

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Substitute for form 1449A/PTO				Complet if Known		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Application Number		
				Filing Date		
				First Named Inventor	Shahab Khandan	
				Art Unit		
(use as many sneets as necessary)				Examiner Name		
Sheet	1	of	2	Attorney Docket Number	4887P327D2	

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Document Number Number - Kind Code ² (if known)	Publication Date Issue Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
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Examiner Initials*	Cite No.1	Foreign Patent Document Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶			
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¹Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

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Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Complete if Known		
				Application Number		
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				Art Unit		
(use as many sneets as necessary)				Examiner Name		
Sheet	2	of	2	Attorney Docket Number	4887P327D2	

	NON PATENT LITERATURE DOCUMENTS					
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²			
		J.G. Jonesa, et al., "In-situ control of chemical vapor deposition for fiber coating," Abstract, Materials and Manufacturing Directorate, Air Force Research Laboratory, Wright-Patterson AFB, OH 45433, December 1997				
		Z. Yu, et al., "Influence of oxygen and nitrogen on the growth of hot-filament chemical vapor deposited diamond films," Abstract, Thin Solid Films 1999, 342:1-2:74-82				

Examiner	Date
Signature	Considered

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